

12-18-01

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Docket No.: M-12350 US

December 13, 2001

Box Patent Application  
Commissioner For Patents  
Washington, D. C. 20231

Enclosed herewith for filing is a patent application, as follows:

Inventor: Pablo I. Rovira

Title: Optical Metrology System With Combined Interferometer and Ellipsometer

☒ Return Receipt Postcard  
☒ This Transmittal Letter (in duplicate)  
12 pages Specification (not including claims)  
4 pages Claims  
1 page Abstract  
9 Sheets of Drawings consisting of Figs. 1, 2, 3A, 3B, 4, 5A, 5B, 6, 7A, 7B, 7C, 8, 9 and 10  
2 pages Declaration For Patent Application and Power of Attorney  
1 page NonPublication Request  
1 page Recordation Form Cover Sheet (in duplicate)  
1 page Assignment  
1 page PTO Form 1449 citing 4 references  
☒ Copies of 4 Cited References submitted

☒ Applicant asserts entitlement to small entity status for the attached patent application**CLAIMS AS FILED (fees computed under 37 CFR §1.9(f))**

For	Number Filed		Number Extra		Rate		Basic Fee
Total Claims	25	-20 =	5	x	\$ 9.00	=	\$ 45.00
Independent Claims	4	-3 =	1	x	\$42.00	=	\$ 42.00
<input type="checkbox"/> Fee of _____ for the first filing of one or more multiple dependent claims per application							\$
<input type="checkbox"/> Fee for Request for Extension of Time							\$

Please make the following charges to Deposit Account 19-2386:

- ☒ Total fee for filing the patent application in the amount of \$ 457.00  
☒ The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account 19-2386.

EXPRESS MAIL LABEL NO:

EL 884 816 194 US

Respectfully submitted,



 Michael J. Halbert  
 Attorney for Applicant  
 Reg. No. 40,633

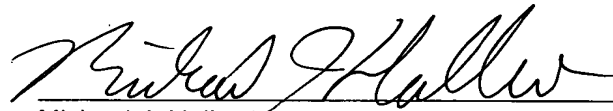
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MODIFIED PTO/SB/35 (11-00)

<b>REQUEST AND CERTIFICATION UNDER 35 U.S.C. 122(b)(2)(B)(i)</b>	Inventors	Pablo I. Rovira
	Title	Optical Metrology System With Combined Interferometer and Ellipsometer
	Atty Docket Number	M-12350 US

I hereby certify that the invention disclosed in the attached application **has not and will not be** the subject of an application filed in another country, or under a multilateral agreement, that requires publication at eighteen months after filing. I hereby request that the attached application not be published under 35 U.S.C. 122(b).

December 13, 2001  
Date



Michael J. Halbert  
Attorney for Applicants  
Reg. No.: 40,633

This request must be signed in compliance with 37 CFR 1.33(b) and submitted with the application **upon filing**.

Applicant may rescind this nonpublication request at any time. If applicant rescinds a request that an application not be published under 35 U.S.C. 122(b), the application will be scheduled for publication at eighteen months from the earliest claimed filing date for which a benefit is claimed.

If applicant subsequently files an application directed to the invention disclosed in the attached application in another country, or under a multilateral international agreement, that requires publication of applications eighteen months after filing, the applicant **must** notify the United States Patent and Trademark Office of such filing within forty-five (45) days after the date of the filing of such foreign or international application. **Failure to do so will result in abandonment of this application (35 U.S.C. 122(b)(2)(B)(iii)).**

7 CFR 1.213(a) provides for a request that an application not be published under 35 U.S.C. 122(b). Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. SEND TO: Commissioner for Patents, Washington, DC 20231.